Electronic Acknowledgement Receipt					
EFS ID:	1007201				
Application Number:	10065095				
Confirmation Number:	6154				
Title of Invention:	Process and apparatus for minimizing thermal gradients across an advanced lithographic mask				
First Named Inventor:	Louis M. Kindt				
Correspondence Address:	Richard M. Kotulak  IBM Corporation  IP Law Department, 972E  1000 River Street  Essex Junction  VT  05452  US  -				
Filer:	Richard M. Kotulak/Gemma Montani				
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Application Type:	Utility				
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## File Listing:

Submitted with Payment

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Supplemental Response or Supplemental Amendment	BUR920020016US1Amend mentMarch022006.pdf	665247	no	7
Warnings:				•	
	Total Files Size (in bytes): 665247				

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## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

## National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.